



1765

the United States Patent and Trademark Office

Re the Application of
Texas Instruments, et al.

TI-24521

Serial No.: 09/732,468

Art Unit: 1765

Filed: December 7, 2000

Examiner: V. Perez-Ramos

Title: Method for Unpatterned Resist Etch Back of Shallow
Trench Isolation Refill Insulator

March 20, 2002

Assistant Commissioner for
Patents
Washington, D. C. 20231

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)
I hereby certify that the above correspondence is
being deposited with the U.S. Postal Service as
U.S. Mail in an envelope addressed to: Assistant
Commissioner for Patents, Washington, D.C. 20231
on March 20, 2002.
Lawrence J. Bassuk
Lawrence J. Bassuk, Reg. No. 29,043

Dear Sir:

Transmitted herewith is an amendment in this application.

The fee has been calculated as shown below.

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TC 1700

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
Total Claims	21	Minus	21	= 0	x \$18 =	\$ 0
Ind. Claims	1	Minus	3	= 0	x \$84 =	\$ 0
TOTAL ADDITIONAL FEE FOR THIS AMOUNT						\$ 0

Under 37 C.F.R. § 1.16(k) please charge the total additional fee,
and any further fees, or credit overpayment to Deposit Account of
Texas Instruments Incorporated, No. 20-0668.

Respectfully submitted,
Lawrence J. Bassuk
Lawrence J. Bassuk
Reg. No. 29,043
Attorney for Applicants

Texas Instruments Incorporated
P.O. Box 655474, M/S 3999
Dallas, Texas 75265
(972) 917-5458



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#6
na
3/29/02

In Re the Application of
Bowles, et al.

TI-24521

Serial No.: 09/732,468

Art Unit: 1765

Filed: December 7, 2000

Examiner: V. Perez-Ramos

Title: Method for Unpatterned Resist Etch Back of Shallow
Trench Isolation Refill Insulator

Response under 37 CFR 1.111

March 20, 2002

Assistant Commissioner of Patents
Washington, DC 20231

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Assistant Commissioner for Patents, Washington,
D.C. 20231 on March 20, 2002
Lawrence J. Bassuk
Lawrence J. Bassuk, Reg. No. 29,043

Dear Sir:

Applicants respond to the Office communication dated
December 20, 2001 as follows:

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